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SERIAL NUMBER 10/812,591	FILING OR 371(c) DATE 03/29/2004 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. SLA0786
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7/15 ** CONTINUING DATA *****

This application is a CIP of 10/801,374 03/15/2004 and is a CIP of 10/801,377 03/15/2004

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/07/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY WA	SHEETS DRAWING 11	TOTAL CLAIMS 36	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance				

Verified and
Acknowledged

Examiner's Signature Initials

ADDRESS

27518

TITLE

HIGH DENSITY PLASMA PROCESS FOR THE FORMATION OF SILICON DIOXIDE ON SILICON CARBIDE
SUBSTRATES

FILING FEE RECEIVED 2916	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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